

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	application Miller e		·	Group Art Unit: 2862 Examiner: Unknown
	Willer C	t ai.	§ §	Examiner. Officiowir
Serial 1	No. 10/61	6,086	§ 8	Atty. Dkt. No. 5589-03501
Filed: For:	METHO DETER	DS AN MININ	ND SYSTEMS FOR G A PROPERTY OF SING FILM SING SILM	I hereby certify that this correspondence is being deposite with the U.S. Postal Service as First Class Mail in an envelop addressed to: Assistant Commissioner for Patents, Washington D.C. 20231, on the date indicated below: 11-3-03
			INFORMATION DISCL	OSURE STATEMENT
	ant Comm ngton, D.C		r for Patents	
		lditiona	l information identified below	references listed on the attached Form PTO-1449 in paragraph 3. A copy of each reference listed on
1.	This Info	ormatio	on Disclosure Statement is sub-	nitted:
	a.		prosecution application under within 3 months of the date of an International application; before the mailing date of a fi	f entry of the national stage as set forth in § 1.491 in rst Office Action on the merits; or st Office Action after the filing of a request for
	b.		Office Action or Notice of	ragraph 1a and prior to the mailing date of a final fallowance, and thus: \Box the certification of d, or \Box a fee of \$180.00 is enclosed.
	c.		_	al Office Action or a Notice of Allowance and prior and thus: the certification of paragraph 2 below is

2.	It is h	It is hereby certified:				
		that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Statement, or				
		that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56 (c) more than three months prior to the filing of the Statement.				
3.		Consideration of the following additional information (including any co-pending or abandoned U.S. applications, prior uses and/or sales, etc.) is requested:				
4.	For ea	ach non-English language reference listed on the attached Form PTO-1449:				
		reference is made to an English language translation submitted herewith, and/or				
		reference is made to a foreign patent office search report (in the English language) submitted herewith, and/or				
		reference is made to an English language translation of a foreign patent office search report submitted herewith, and/or				
		reference is made to the concise explanation contained in the specification of the present application at page(s), and/or				
		reference is made to the concise explanation set forth below:				
5.		Applicant also offers the following comments for the Examiner's consideration:				
6.		Also enclosed is a copy of a foreign search report citing these references.				
7.		The listed documents were brought to the attention of the Applicant(s) after payment of the issue fee in the captioned case. The documents were cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Applicant(s) request this Information Disclosure Statement and attached Form PTO-1449 be placed in the file of the captioned application.				
8.		Applicant(s) requests that the Information Disclosure Statement and attached Form PTO-1449 and references, which are being filed before the grant of the patent and pursuant to 37 C.F.R. § 1.97(i), be placed in the file of the captioned application.				

If any required fees are missing, the Commissioner is authorized to charge said fees to Conley, Rose & Tayon, P.C. Deposit Account No. 03-2769/5589-03501.

Respectfully submitted,

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Ann Marie Mewherter

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Agent for Applicant(s)

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Date: 10-29-03

SUB

FILING DATE IF

Form PTO-1449 (modified) List of Patents and Publications TRADE

For Applicant's Information **Disclosure Statement** (Use several sheets if necessary)

REF.

EXAM.

ATTY. DKT. NO. 5589-03501

SERIAL NO. 10/616,086

APPLICANT: Miller et al.

GROUP: 2862

CLASS

FILING DATE: July 9, 2003

	u.s. patent	r documents
DOCUMENT NUMBER	DATE	NAME

INITIALS	DES.	DOCOMENT NOMBER	DAIL		OLAGO	CLASS	APPROPRIATE		
	A1	4599558	7/1986	Castellano, Jr. et al.					
	A2	4812756	3/1989	Curtis et al.		_			
	A3	5485091	1/1996 1/1997 7/1997 7/1997 6/1998 8/2000	Verkuil Verkuil et al. Verkuil Fung et al. Verkuil et al. Verkuil et al.		.			
	A4	5594247				<u> </u>			
	A5	5644223							
	A6	5650731							
	A7	5767693							
	A8	6097196							
	A9	6202029	3/2001	Verkuil et al.					
		FOR	REIGN PATE	NT DOCUMENTS					
EXAM. INITIALS	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO		
		OTHER ART (Inc	luding Author	r, Title, Date, Pertinent Pa	ages, Etc.)	<u> </u>		
	A10	Numerical Recipes in C, The Art of Scientific Computing, 2nd Ed., © Cambridge University Press 1988, 1992, p. 683.							
	A11	Weinberg, "Tunneling of Electrons from Si into Thermally Grown SiO ₂ ," Solid-State Electronics, 1977, Vol. 20, pp. 11-18.							
	A12	Verkuil, "Rapid Contactless Method for Measuring Fixed Oxide Charge Associated with Silicon Processing," IBM Technical Disclosure Bulletin, Vol. 24, No. 6, 1981, pp. 3048-3053.							
	A13	"Contactless Photovoltage vs. Bias Method for Determining Flat-Band Voltage," IBM Technical Disclosure Bulletin, Vol. 32, Vol. 9A, 1990, pp. 14-17.							
**************************************	A14	"Contactless Electrical Equivalent Oxide Thickness Measurement," IBM Technical Disclosure Bulletin, Vol. 29, No. 10, 1987, pp. 4622-4623.							

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.